



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 7422

SERIAL NUMBER 10/680,216	FILING DATE 10/08/2003 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. P8375.0002
-----------------------------	---------------------------------------	--------------	------------------------	--------------------------------------

APPLICANTS

Hidemitsu Aoki, Kanagawa, JAPAN;

Yoshiko Kasama, Kanagawa, JAPAN;
Tatsuya Suzuki, Kanagawa, JAPAN;

** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 2002-303629 10/17/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 12/31/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 14	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

ADDRESS

32172
 DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP
 1177 AVENUE OF THE AMERICAS (6TH AVENUE)
 41 ST FL.
 NEW YORK, NY
 10036-2714

TITLE

Method of manufacturing semiconductor device and apparatus for cleaning substrate

FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)